INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 15, 2026

IGI Report Number	LG791655426
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	10.21 X 5.47 X 3.44 MM

GRADING RESULTS

Carat Weight	1.26 CARAT
Color Grade	D
Clarity Grade	VVS 2

ADDITIONAL GRADING INFORMATION

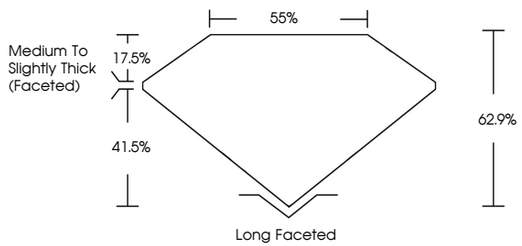
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG791655426

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG791655426

Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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Carat Weight	1.26 CARAT
Color Grade	D
Clarity Grade	VVS 2

55%
Medium To Slightly Thick (Faceted)
17.5%
41.5%
62.9%
Long Faceted

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG791655426

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IGI

April 15, 2026
IGI Report No LG791655426
OVAL BRILLIANT
10.21 X 5.47 X 3.44 MM
Carat Weight 1.26 CARAT
Color Grade D
Clarity Grade VVS 2
Depth 62.9%
Table 55%
Girdle Medium To Slightly Thick (Faceted)
Culet Long Faceted
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG791655426
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa